



MIT. 9889

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Lee et al.

SERIAL NO: 10/603,712

FILED: June 25, 2003

FOR: METHOD FOR IMPROVING HOLE MOBILITY
ENHANCEMENT IN STRAINED SILICON
P-TYPE MOSFETS

Assistant Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Mail Stop: Issue Fee

Sir:

CHANGE OF CORRESPONDENCE ADDRESS

Applicant's representative requests that the correspondence address for the above application be changed to:

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Respectfully submitted,

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents and Trademarks, P.O. Box 1450, Alexandria, VA 22313-1450, Mail Stop: Issue fee

Elizabeth M. Ball

9/20/2005

Date